

Nanolamellar & 2D Materials

Context

- MAX, MAB, and MXene material family features nanolamellar structures with unique anisotropic physical properties
- Control elemental composition and surface chemistry to design dedicated physicochemical properties for targeted applications
- Lamellar metal dichalcogenides as 2D materials for next generation microelectronics

Objectives

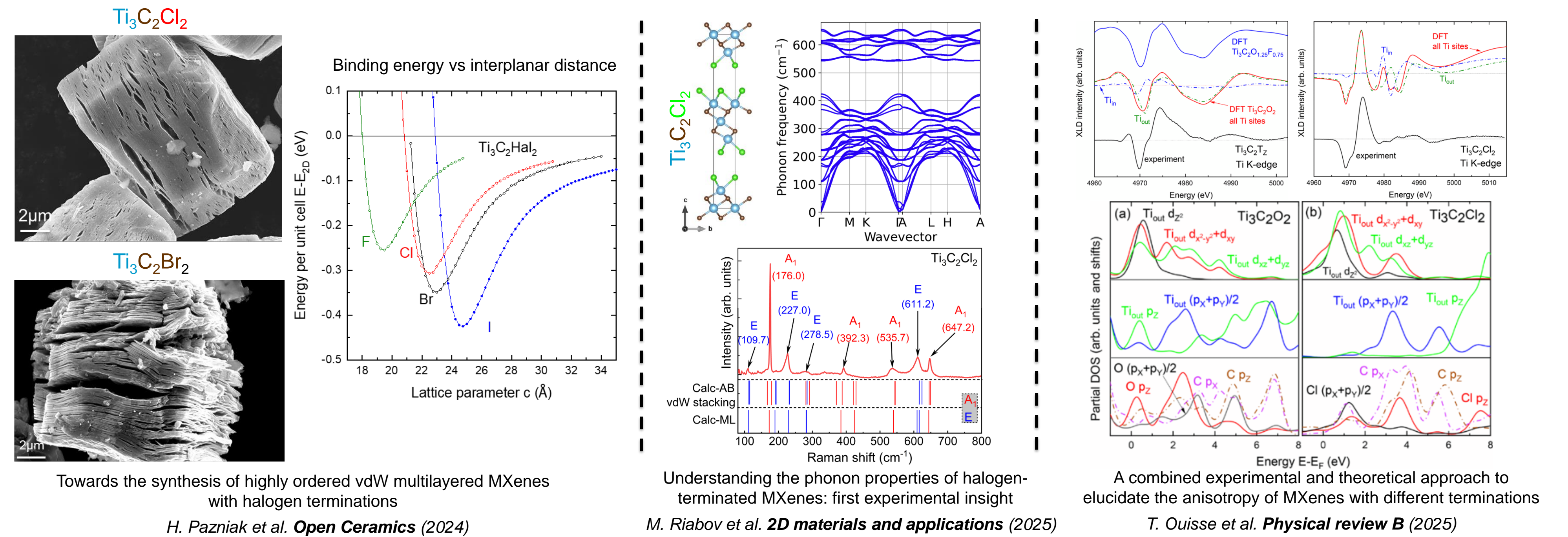
- Develop MAX phases & related MXenes with new chemistries and controlled surface terminations
- Investigate structural and anisotropic physical properties using advanced characterization techniques in lab- and large-scale facilities, which are further coupled with density-functional theory (DFT) calculations
- Synthesize lamellar metal sulfides ultra-thin films & dedicated heterostructures for microelectronics

Skills and competences

- Materials synthesis: single crystal growth and chemical exfoliation, atomic / molecular layer deposition (ALD / MLD)
- Advanced structural & physical characterization: Complementary *in situ* and operando studies during synthesis or not, using lab- & large-scale facilities (i.e. synchrotron radiation)

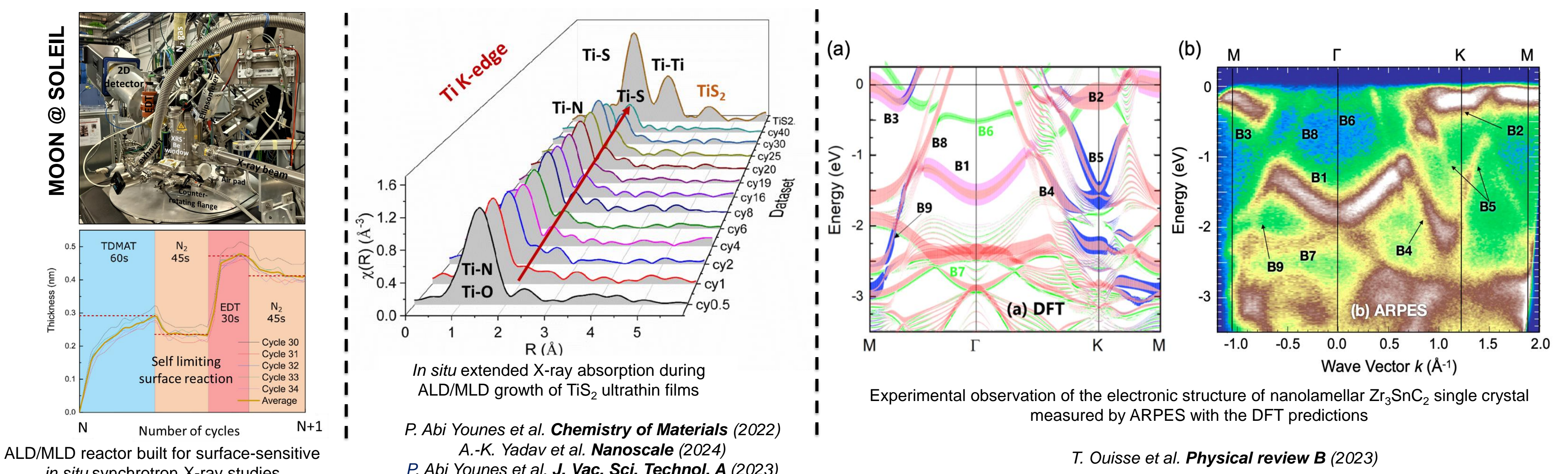
2D MXenes: Synthesis and Characterization

We develop sustainable and eco-friendly routes to synthesize 2D MXenes with varied transition metals, and precisely control surface chemistry to achieve targeted functional groups and properties.



Advanced Characterization for *in Situ* / *Operando* & Fundamental Studies

We combine *in situ*, *operando*, and synchrotron-based characterization techniques to elucidate thin-film growth mechanisms and to probe the intrinsic electronic structure of lamellar materials.



Wide & Ultra-Wide Bandgap Semiconducting Oxides

Context

- ZnO & Ga₂O₃ and related materials
- Remarkable structural and physical properties, opening the way for next generation devices
- Understand the fundamental mechanisms related to their nucleation, epitaxial growth, doping, and alloying to control their morphology & properties

Objectives

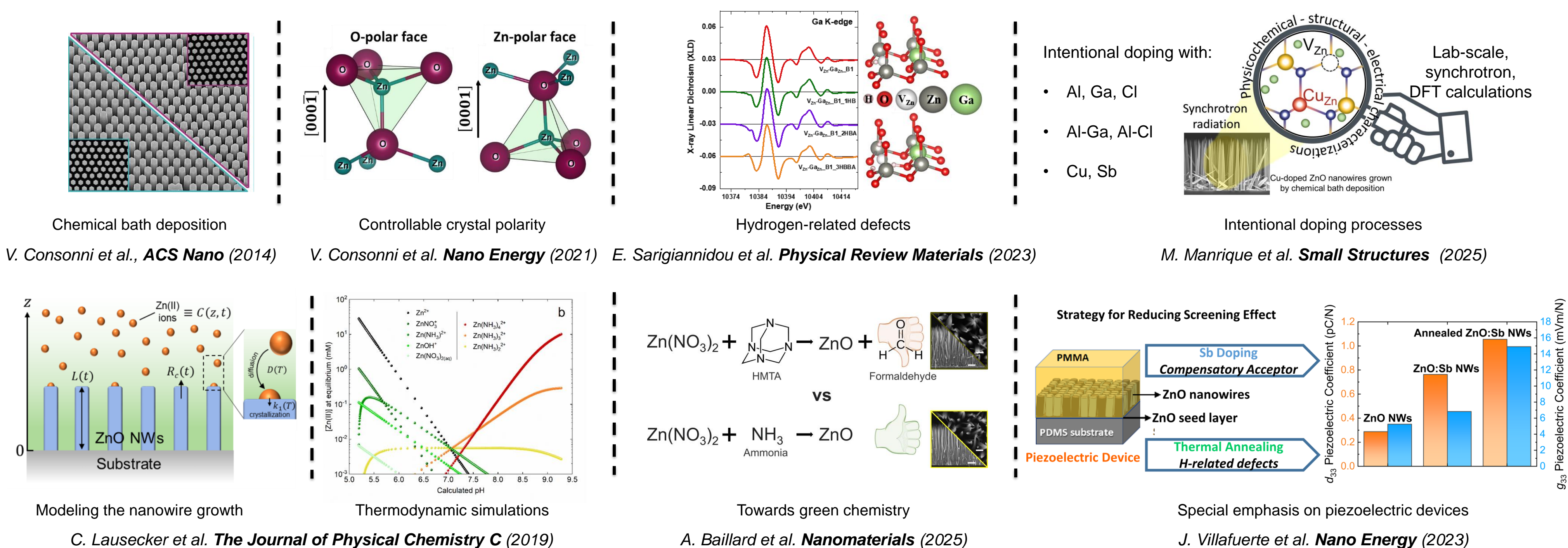
- Develop the epitaxial growth of semiconducting oxide nanowires & thin films by chemical deposition techniques, including CBD, ALD & PLI-MOCVD
- Elucidate the physicochemical processes for the nucleation, epitaxial growth, doping, and alloying by combining with thermodynamic computations
- Explore & control their physical properties: defects, doping, alloying, interface / surface
- Combine nanowires and thin films into innovative heterostructures: piezoelectric, power electronic and optoelectronics devices
- Assess raw materials criticality & process impact

Skills and competences

- Growth modelling, doping, alloying
- Thermodynamic simulations, green chemistry
- Structure-property relationship: polarity, interface / surface, epitaxy
- Techniques: sol-gel process, CBD, SILAR, ALD / ALE, PLI-MOCVD, and morphological / structural / chemical / optical characterization

Epitaxial ZnO Nanowires: Growth & Properties

We develop the spontaneous & selective area growth of ZnO nanowires by chemical bath deposition to thoroughly control their morphology & physical properties for piezoelectric & photocatalytic devices.



Ga₂O₃ Nanomaterials & Epitaxial Thin Films: Growth & Properties

We develop the chemical bath deposition of Ga₂O₃ nanomaterials and the epitaxial growth of Ga₂O₃ thin films by ALD & PLI-MOCVD to thoroughly control their morphology & physical properties for power electronics & optoelectronics.

